



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Small et al.
Title: Compositions for Chemical Mechanical Planarization of Copper
Application No.: 10/017,934 Filing Date: December 12, 2001
Examiner: Umez Eronini, Lynette T. Group Art Unit: 1765
Docket No.: CHEM.001US0 Conf. No.: 1435

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Signature

Julien Bow

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

A petition for a five-month extension of time within which to respond to the June 12, 2003 outstanding Office Action is respectfully requested, such extension allowing the undersigned until December 12, 2003 to respond.

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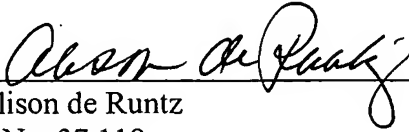
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A check for \$2010.00 is enclosed to cover the fee for a five-month extension of time.

Respectfully submitted,


K. Alison de Runtz
Reg. No. 37,119

12/12/03
Date

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